

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q90882

**Yoshinori IWABUCHI et al**

Conf. No.: **2218**

Appln. No.: **10/553,190**

Group Art Unit: **2812**

Filed: **October 13, 2005**

Examiner: **Band, M.**

For: **METHOD FOR FORMING POROUS THIN FILM**

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 2, 2008, please amend the above-identified application as follows on the accompanying pages.

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